



Byung Gwon Lee

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Mr. Byung Gwon Lee is a patent attorney at Shin & Kim. Mr. Lee's main areas of practice include patent application, trial, and litigation related to display, semiconductor, electrical, electronic, and telecommunications, and advisory on related intellectual property rights.

Professional Career

2022.12-Present Shin & Kim LLC
2022.7-2022.11 LG Display

Education

2014-2022 Korea University, College of Engineering (B.E., Electrical Engineering)

Qualifications

2022 Admitted to patent bar, Korea

Languages

Korean, English

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